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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 4004

SERIAL NUMBER 10/606,135	FILING DATE 06/25/2003  RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. 199372002501
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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 09/628,235 07/28/2000 PAT 6,613,692

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 11-216675 07/30/1999

JAPAN 11-323869 11/15/1999

JAPAN 11-354800 12/14/1999

JAPAN 2000-000982 01/06/2000

JAPAN 2000-015816 01/25/2000

JAPAN 2000-119249 04/20/2000

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/25/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 30	TOTAL CLAIMS 14	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>				

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## TITLE

Substrate processing method and apparatus

☐ All Fees

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